

10/659,778

FIS919990263US2

DEC 15 2004

I hereby certify that this paper and fee are being TRANSMITTED VIA FACSIMILE TO: Assistant Commissioner for Patents, P. O. Box 1450, ALEXANDRIA, VA 22313-1450. Date of Deposit: 12/15/04 Name of Person Making Deposit: Linda Roberts-Jackson

Signature

In the United States Patent and Trademark Office

Date: 12/15/04

In re Application Edward Barth, et al.

Filed: 9/10/03

of:

For:

Dual-Damascene Interconnect Structure Using
Low Stress Fluorosilicate Insulator with Copper
Conductors

Serial Number: 10/659,778

Confirmation No. 5616

Art Unit: 2822

Examiner:

Novacek, Christy L.

AMENDMENT

Hon. Commissioner of Patents and Trademarks
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated October 15, 2004, Applicants submit
the following amendments and remarks: